

SCHMEISER, OLSEN & WATTS LLP**INTELLECTUAL PROPERTY LAW**

ALBERT L. SCHMEISER
ARLEN L. OLSEN, MS
JACK P. FRIEDMAN, Ph.D.
KRISTEN L. ASHDOWN
KENNETH C. BOOTH*
JOSEPH J. CHRISTIAN
PACER K. UDALL*
ANTHONY M. PALAGONIA †
SANDER M. RABIN, MD
GERALD F. DUDDING, Ph.D. †
DAVID E. ALLRED †
JOHN BURTON
KHOI D. NGUYEN*

3 LEAR JET LANE, SUITE 201
LATHAM, NEW YORK 12110
(518) 220-1850
FACSIMILE (518) 220-1857
www.iplawusa.com
E-MAIL - NY@iplawusa.com

OTHER OFFICES

18 E. UNIVERSITY DRIVE
SUITE 101
MESA, ARIZONA 85201
(480) 655-0073
FACSIMILE (480) 655-9536
E-MAIL - AZ@iplawusa.com

OF COUNSEL

CHARLES T. WATTS ††
JEFFREY L. THOMPSON*

- * Other than NY Bar
- † Patent Agent
- †† Retired

TECHNICAL STAFF

MARK J. FRIEDMAN
TALLIE J. ANDERSON

PARALEGALS

LISA A. MOLLOY
JOYCE PATRICK-BAL, MS
TAMBRA L. WHITE
KIMBERLY A. DWILESKI

TELECOPY MESSAGE

FOR: Examiner Julio Maldonado

COMPANY: Patent and Trademark Office

FROM: Jack Friedman

DATE: 11/06/2003

NUMBER OF PAGES TO FOLLOW: 25 + cover.

MESSAGE: U. S. Patent Application Serial No. 09/599,783. Attached is the Amendment filed January 30, 2003, and the return postcard with the Patent and Trademark Office postmark showing it was received February 4, 2003. Thank you.

If you do not receive any of the pages, please call (518) 220-1850

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UTILITY/DESIGN PATENT
(amend/final amend) Date: 11/30/03
Date of O.A.: 11/10/02
Rec'd in the U.S. Patent & Trademark Office on the date stamped hereon via
Certificate of Mail: 15+ COASD
Case # BVA-99-197 S/N: 09/599783 Filed: 6/22/00
Pat. # _____ Issued: _____
Examiner: Julian G. Haldarada Art Unit: 2823
Batch: _____ Atty: JPE
Applicant: HyunKang et al
Title: Method for Etching a Semiconductor...
☒ Transmittal in duplicate _____ ☒ Amendment in _____ pgs.
☐ _____ Mo. Ext. Time in dupe. ☐ Change of Address
☐ Request for Drawing Changes ☐ Small Entity Statement
☐ _____ pgs. _____ Drawings ☐ Assignment in _____ pgs.
☐ \$ _____ Check for Amend. ☐ \$ _____ Check for Assig.
☐ Information Disclosure Statement; PTO-1449 in duplicate with _____ Reference(s)
☐ _____

TBM-9812
UTILITY/DESIGN PATENT Date: 11/30/03
(amend/final amend) Date of O.A.: 11/10/02
Rec'd in the U.S. Patent & Trademark Office on the date stamped hereon via
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☐ \$ _____ Check for Amend. ☐ \$ _____ Check for Assig.
☐ Information Disclosure Statement; PTO-1449 in duplicate with _____ Reference(s)
☐ _____

**TRANSMITTAL LETTER
(General - Patent Pending)**Docket No.
BU9-99-197

In Re Application Of: Furukawa et al.

Serial No.
09/599,783Filing Date
6/22/2000Examiner
Julio J. MaldonadoGroup Art Unit
2823

Title: METHOD FOR ETCHING A SEMICONDUCTOR SUBSTRATE USING GERMANIUM HARD MASK

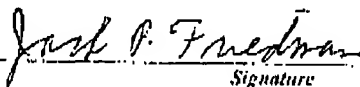
TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is:

Amendment

in the above identified application.

- ☒ No additional fee is required.
- ☐ A check in the amount of _____ is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 09-0456(IBM) as described below. A duplicate copy of this sheet is enclosed.
- ☐ Charge the amount of _____
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.


Signature

Dated: 1/30/2003

Jack P. Friedman
Reg. No. 44,688
Schmeiser, Olsen & Watts
3 Lear Jet Lane, Suite 201
Latham, NY 12110
(518) 220-1850

I certify that this document and fee is being deposited
on 1/30/2003 with the U.S. Postal Service as
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Assistant Commissioner for Patents, Washington, D.C.
20231.


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Kim Dwileski

Typed or Printed Name of Person Mailing Correspondence

CC:

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application: Furukawa, et al

Group Art Unit: 2823

Serial No.: 09/599,783

Examiner: Julio J. Maldonado

Filed: 06/22/2000

Docket No.: BU9-99-197

Title: Method For Etching A Semiconductor Substrate Using Germanium Hard Mask

Commissioner for Patents
Washington, DC 20231

Sir:

This paper is being filed in response to a Office Action dated November 6, 2002 in connection with the above-identified application. Reconsideration and allowance are respectfully requested in view of the Amendments and Remarks below.

Amendment

Please amend the above-referenced patent application as follows:

In the Claims

Please add new claims 33-43. Claims 3-6, 8, 11, 14, 19, 21, 26, 28, 30, and 32 are amended herein, as marked up in Appendix A. Claims 12 and 20 were amended prior to the present office action response. Currently pending claims 3-6, 8, 11-12, 14, 19-21, 26-28, 30, and 32-43 for consideration by the Examiner are as follows:

09/599,783

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